

Form PTO-1449

Doc No (Number) (Optional)

Application Number

TSMC-01-039C

10/798,992

Applicant

Shu-Ying Cho et al.

Filing Date

03/12/04

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INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	TITLE	CLASS	SUBCLASS	ALSO DATE IF APPROPRIATE
WL	5538914	7/23/96	Chiu et al.	437	48	8/3/95
WL	6133101	10/17/00	Wu	438	276	4/9/98
WL	6087699	7/11/00	Wann et al.	257	384	11/25/97
WL	5940710	8/17/99	Chung et al.	438	305	3/5/96
WL	5480822	1/2/96	Hsue et al.	437	48	11/28/94

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Portion Pages, Etc.)

EXAMINER

DATE COMPLETED

7/22/04

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